

<b>Notice of References Cited</b>	Application/Control No. 10/521,848		Applicant(s)/Patent Under Reexamination VAN DER VEEN ET AL.	
	Examiner DARREN SCHWARTZ		Art Unit 2435	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0054149 A1	12-2001	Kawaguchi et al.	713/175
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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#### FOREIGN PATENT DOCUMENTS

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#### NON-PATENT DOCUMENTS

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